THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Raulf M. Polichar, et al.

Application No.:

09/736,157

Examiner:

KIN CHAN CHEN

Filed:

December 15, 2000

Group Art Unit:

1765

Atty. Docket No.:

SAIC0010-US

For:

PIN ALLOY-SEMICONDUCTOR, RADIATION DETECTORS WITH RECTIFYING JUNCTION CONTACTS, METHODS AND SYSTEMS FOR FORMING PIN ALLOY-SEMICONDUCTOR DEVICES WITH RECTIFYING JUNCTION CONTACTS, AND SYSTEMS AND METHODS FOR ANALYZING ALLOY-SEMICONDUCTOR

PROPERTIES

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

TC 1700 ED In response to the Office Action dated May 6, 2002, Applicants respectfully request entry of the following remarks into the file of the above identified application.

REMARKS

On page 2 of the Office Action, a restriction requirement pursuant to 35 U.S.C. § 121 was imposed on the pending claims requesting election of one of the following groups for purposes of examination:

- I. Claims 1 12, drawn to a method, classified in Class 438, subclass 708; and
- II. Claims 13 24, drawn to a product device, classified in Class 250, subclass 370.